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Complete If Known

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number		New Application	
				Filing Date		February 3, 2006	
				First Named Inventor		Tomoaki NAKAYAMA	
				Group Art Unit			
				Examiner Name			
				Confirmation No.			
				Sheet	1	of	2

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		
	1.	6,715,324	B2	Okamoto	4/6/04
	2.	6,578,389	B1	Okamoto et al	6/17/03

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code.

⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /LDW/

/DANNY WORRELL/ (7/6/08)

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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)			
	3.	JP	2003-41461	A	Kabushiki Kaisha Inoue	2/13/03	AB
	4.	JP	3-75656	B2	Shima Seiki Mfg., Ltd.	12/2/91	
	5.	JP	10-1852	A	Shima Seiki Mfg., Ltd.	1/6/98	AB
	6.	JP	8-49144	A	Shima Seiki Mfg., Ltd.	2/20/96	AB
	7.	JP	61-49420	B2	Shima Seiki Mfg., Ltd.	10/29/86	
	8.	WO	01/61092	A1	Shima Seiki Mfg., Ltd.	8/23/01	
	9.	WO	01/16416	A1	Shima Seiki Mfg., Ltd.	3/8/01	
	10.	JP	10/60758	A	Shima Seiki Mfg., Ltd.	3/3/98	AB
	11.	JP	2000-154447	A	Shima Seiki Mfg., Ltd.	6/6/00	AB
Examiner Signature	/DANNY WORRELL/ (7/6/08)				Date Considered		

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